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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Gary W. Ferrell et al

U.S. Serial No: 09/ 034,369

Group Art Unit: 3744

Date Filed: 3 March 1998

Examiner: S. Gravini

Title: "CHEMICAL DRYING AND CLEANING SYSTEM"

RECEIVED

Assistant Commissioner for Patents
Washington, D.C. 20231

JUN 23 1999

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Publishing Division
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SUBMISSION OF ISSUE FEE AND SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT

Dear Sir:

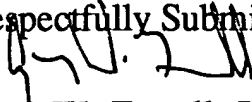
In response to the Notice Of Allowance, mailed 15 March 1999, for the above-identified patent application, the Applicants herewith submit a check for \$635. for the Issue Fee and an advance order of ten copies of the patent.

The Applicants also submit herewith a check for \$240., a supplemental Information Disclosure Statement and two references that were brought to the Applicants' attention about six weeks ago. The first reference appears to be a laid-open patent application, WO 96/22356 (PCT/US96/00336), entitled 'Cleaning Process And Composition'. As yet, the Applicants have only obtained pages 1, 3-4, 15-19 and 55 of the laid-open patent application for evaluation. The Applicants are attempting to obtain a copy of the full laid-open application so that the Applicants and the Examiner can evaluate whether this reference, which appears to deal with much heavier fluorinated and nitrogenated ethers, is material. The Applicants hope to submit a full copy of this laid-open patent application to the Examiner for review within the next two weeks and to promptly review and respond to the full reference themselves.

The Applicants also submit herewith a copy of U.S. Patent No. 5,275,669, issue to Van Der Puy et al, describing various hydrofluorocarbon solvents that are useful for dissolving or removing contaminants from a substrate.

The Applicants, Gary W. Ferrell, Robert Elson and John F. Schipper, hereby aver that they have learned of the two background references submitted herewith within the last 90 days and that they were not aware of these references and their contents before approximately 1 May 1999. The Applicants apologize for submitting these references for review at this time.

Respectfully Submitted,



Gary W. Ferrell, Inventor



Robert Elson, Inventor



John Schipper, Inventor and

Patent Attorney for Applicants

Date: 15 June 1999

Date: 15 June 1999

Date: 15 June 1999